

Numerical Simulation of Tunneling Effects in Nanoscale Semiconductor Devices Using Quantum Corrected Drift–Diffusion Models

Giuseppe Cassano, Claudio Giulianetti, Riccardo Sacco

*Dipartimento di Matematica “F. Brioschi”,
Politecnico di Milano, via Bonardi 9, 20133 Milano, Italy*

Carlo de Falco

*Dipartimento di Matematica “F. Enriques”,
Università degli Studi di Milano, via Saldini 50, 20133 Milano, Italy*

Abstract

In this article, we deal with the numerical approximation of a Quantum Drift–Diffusion model capable of describing tunneling effects through the thin oxide barrier in nanoscale semiconductor devices. We propose a novel reformulation of the mathematical model that allows a natural generalization of the Gummel decoupled algorithm, widely adopted in the case of the Drift-Diffusion system. Then, we address the finite element discretization of the linearized problems obtained after decoupling, and we prove well-posedness and a discrete maximum principle for the solution of the continuity equations. Finally, we validate the physical accuracy and the numerical stability of the proposed algorithms on the simulation of a real-life nanoscale device.

Key words: Quantum Drift–Diffusion Models, Functional Iterations, Finite Element Method, Nanoscale Semiconductor Devices, Tunneling.
